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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Shigeyuki MARUYAMA et al.**

Group Art Unit: **2815**

Application Number: **09/577,932**

Examiner: **Chris C. Chu**

Filed: **May 25, 2000**

Confirmation Number: **4823**

For: **SEMICONDUCTOR DEVICE HAVING AN ALIGNMENT MARK FORMED BY
THE SAME MATERIAL WITH A METAL POST**

Attorney Docket Number: **000663**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.312

MAIL STOP: IF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

April 6, 2006

Sir:

Subsequent to issuance of a Notice of Allowance in the above-referenced application, the following amendment and remarks are respectfully submitted.

Amendment to the Drawing begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.